Application/Control No.	Applicant(s)/Patent under Reexamination
10/619,958	SUGIURA ET AL.
Examiner	Art Unit
Jacob Y. Choi	2875

SEARCHED					
Class	Subclass	Date	Examiner		
362	26, 561, 621, 622, 612, 626	6/7/2005	JC		
362	624, 628	6/7/2005	JC		
349	65	6/7/2005	JC		
385	146	6/7/2005	JC		
362	608	11/14/2005	JC		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
All Relate (including s abo	earch areas	11/14/2005	JC	

STRATEGY))
DATE	EXMR
6/7/2005	JC
11/14/2005	JC
11/14/2005	JC
	DATE 6/7/2005 11/14/2005